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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

10A15

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10068005	02/08/2002	118		1763	H. B. B.

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**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

REPUBLIC OF KOREA 2001-8175 02/19/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO	
35 USC 119 conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no		262/011
Verified and Acknowledged Examiner's initials			
TITLE : Vacuum apparatus of ion implantation system and evacuation method			
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for 0.8
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.	Print Fig.
TERMINAL		Primary Examiner		
DISCLAIMER		Application Examiner		
PREPARED FOR ISSUE				
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